

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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In re Application of:)
Han-Ming Wu et al.) Examiner: Nguyen, Hung
Serial No: 10/759,641) Art Unit: 2851
Filed: January 16, 2004)
For: Purging Gas from a)
Photolithography Enclosure)
Between a Mask Protective)
Device and a Pattern Mask)

PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Prior to examination of the present RCE application, the Applicants respectfully request that the Examiner enter the following amendments and consider the following remarks.

CERTIFICATE OF FACSIMILE

I hereby certify that this correspondence is being transmitted via facsimile on the date shown below to the United States Patent and Trademark Office.

March 6, 2006

Date of Deposit

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March 6, 2006

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